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Substitute for Form 1449B/PTO

## INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

### Complete if Known

Application Number	09/938,412
Filing Date	August 23, 2001
First Named Inventor	Wan-Thai Hsu, et al.
Group Art Unit	
Examiner Name	
Attorney Docket Number	WOM 0210 PUSP

Sheet

1

of

1

### OTHER PRIOR ART – NON PATENT LITERATURE DOCUMENTS

Examiner Initials	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
HR		HSU, WAN-THAI, ET AL., Geometric Stress Compensation For Enhanced Thermal Stability In Micromechanical Resonators, IEEE International Ultrasonics Symposium, October 5-8, 1998, pgs. 945-948.	

Examiner  
Signature

Helen Kwik

Considered

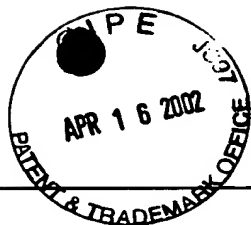
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<sup>2</sup>EP 609. Draw line through citation if not in conformity and

<sup>3</sup>Unique citation designation

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<b>Substitute for Form 1449B/PTO</b>  <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  (use as many sheets as necessary)				<b>Complete if Known</b>	
				Application Number	09/938,412
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				First Named Inventor	Wan-Thai Hsu, et al.
				Group Art Unit	2856
				Examiner Name	
Sheet	1	of	1	Attorney Docket Number	UOM 0211 PUSP
<b>OTHER PRIOR ART -- NON PATENT LITERATURE DOCUMENTS</b>					
Examiner Initials *	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.			T <sup>2</sup>
HK		NGUYEN, CLARK T.-C., Micromachining Technologies For Miniaturized Communication Devices, Proceedings of SPIE: Micromachining and Microfabrications, Santa Clara, CA, September 20-22, 1998, pages 24-38.			
HK		WANG, KUN, ET AL., VHF Free-Free Beam High-Q Micromechanical Resonators, XP-000830790, January 17, 1999, pages 453-458.			
HK		NGUYEN, CLARK T.-C., Frequency-Selective MEMS For Miniaturized Communication Devices, IEEE, 1998, pages 445-460			

Examiner Signature	Helen Kwik	Date Considered	11/15/02
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>1</sup>Unique citation designation number. <sup>2</sup>Applicant is to place a check mark here if English language Translation is attached.